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INFORMATION DISCLOSURE CITATION
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Applicant(s)
Charles A. Dark et al.

Filing Date
January 8, 2002

Group Art Unit
2815

U.S. PATENT DOCUMENTS												
EXAMINER INITIAL	DOCUMENT NUMBER							DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
JN	6	5	6	3	1	8	9	05/13/03	Dark et al.	257	530	06/06/01

FOREIGN PATENT DOCUMENTS												
DOCUMENT NUMBER					DATE	COUNTRY	CLASS	SUBCLASS	Translati n			
									Yes	N		
		</										

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)												
JN	P. Beaud et al., "0.5µm Technology Development and Qualification", [online], [retrieved on 2003-12-14]. Retrieved from the Internet: URL: http://leqwww.epfl.ch/research/pdf/05umf.pdf , pps. 1-2 (unnumbered).											

EXAMINER JOSEPH NGUYEN DATE CONSIDERED 4/5/04

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